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BIB DATA SHEET

CONFIRMATION NO. 1576

SERIAL NUM	BER	FILING or 371(c)	CLASS GF		GROUP ART UNIT		ATTORNEY DOCKET NO.		
10/553,57				427		1715		Serie 6070		
		RULE								
Jean-Mar Takako K Naoki Tai Yuusuke ** CONTINUIN This appli ** FOREIGN AI	Dussar c Girard imura, maoki, Sato, T G DATA ication i	rat, Ibaraki, JAPAN d, Paris, FRANCE; Tsukuba, JAPAN; Tokyo, JAPAN; okyo, JAPAN; A ************************************	**** 4/01346 (**						
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/30/2006										
Foreign Priority claimed Yes No 35 USC 119(a-d) conditions met Yes No Met after Allowance				STATE OR COUNTRY	_	IEETS WINGS	TOTAL CLAIMS		INDEPENDENT CLAIMS	
Verified and /ELIZABETH A BURKHART/ Acknowledged Examiner's Signature Initials			JAPAN		5	18		3		
ADDRESS										
American Intellectua 2700 Pos Suite 180 Houston, UNITED S	al Prope It Oak E 10 TX 770	erty Dept. Boulevard								
TITLE										
Methods for producing silicon nitride films by vapor-phase growth										
	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:					☐ All Fees				
FILING FEE RECEIVED 1220						☐ 1.16 Fees (Filing)				
						☐ 1.17 Fees (Processing Ext. of time)				
						☐ 1.18 Fees (Issue)				
						Other				
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